Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/887,059	CHINO ET AL.	
Examiner	Art Unit	
Nicholas Kim	3622	

SEARCHED					
Class	Subclass	Date	Examiner		
		-			
	*				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
			·		
	<u> </u>				
:					

NOTES RCH STRATEGY)
DATE	EXMR
10/29/2005	NK
10/29/2005	NK
	DATE 10/29/2005